

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of Docket No: Q85660  
Heiji WATANABE, et al.  
Appln. No.: 10/521,311  
Confirmation No.: 1690 Group Art Unit: 2815  
Filed: January 14, 2005 Examiner: WARREN, MATTHEW E  
For: SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD AND  
MANUFACTURING APPARATUS OF THE SAME

**AMENDMENT UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 1, 2008, please amend the above-identified application as follows on the accompanying pages.

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